Exfoliation and Characterization of Bismuth Telluride Atomic Quintuples and Quasi-Two-Dimensional Crystals

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ABSTRACT Bismuth telluride (Bi$_2$Te$_3$) and its alloys are the best bulk thermoelectric materials known today. In addition, stacked quasi-two-dimensional (2D) layers of Bi$_2$Te$_3$ were recently identified as promising topological insulators. In this Letter we describe a method for “graphene-inspired” exfoliation of crystalline bismuth telluride films with a thickness of a few atoms. The atomically thin films were suspended across trenches in Si/SiO$_2$ substrates, and subjected to detail material characterization, which included atomic force microscopy and micro-Raman spectroscopy. The presence of the *van der Waals gaps* allowed us to disassemble Bi$_2$Te$_3$ crystal into its *quintuple* building blocks—five monatomic sheets—consisting of Te$^{(1)}$–Bi–Te$^{(2)}$–Bi–Te$^{(1)}$. By altering the thickness and sequence of atomic planes, we were able to create “designer” nonstoichiometric quasi-2D crystalline films, change their composition and doping, the type of charge carriers as well as other properties. The exfoliated quintuples and ultrathin films have low thermal conductivity, high electrical conductivity, and enhanced thermoelectric properties. The obtained results pave the way for producing stacks of crystalline bismuth telluride quantum wells with the strong spatial confinement of charge carriers and acoustic phonons, beneficial for thermoelectric devices. The developed technology for producing free-standing quasi-2D layers of Te$^{(1)}$–Bi–Te$^{(2)}$–Bi–Te$^{(1)}$ creates an impetus for investigation of the topological insulators and their possible practical applications.

KEYWORDS Bismuth telluride, 2D crystals, atomically thin films, thermoelectrics, topological insulators, graphene-like exfoliation

Bismuth telluride (Bi$_2$Te$_3$) is a unique material with potential for a diverse range of applications. Since the discovery of its extraordinary thermoelectric properties, Bi$_2$Te$_3$ has become a vital component for thermoelectric industry.$^{1–3}$ Bulk Bi$_2$Te$_3$-based materials are known to have the highest thermoelectric figure of merit, $ZT \sim 1.14$ at room temperature (RT). The thermoelectric figure of merit is defined as $ZT = S^2\sigma T/\kappa$, where $S = -\Delta V/\Delta T$ is the Seebeck coefficient ($\Delta V$ is the voltage difference corresponding to a given temperature difference $\Delta T$), $\sigma$ is the electrical conductivity, and $\kappa$ is the thermal conductivity, which has contributions from electrons and phonons. It is clear from the $ZT$ definition that in order to improve thermoelectric figure of merit one should increase the thermopower $S^2\sigma$ and decrease the thermal conductivity. Different approaches have been tried in order to enhance the thermoelectric properties of Bi$_2$Te$_3$ or its alloys. These approaches included the composition change from its stoichiometry, the use of polycrystalline materials with different grain sizes, intentional introduction of structural defects, and incorporation of different dopants, e.g., Sb or Se, into Bi$_2$Te$_3$ lattice. The optimization of bulk Bi$_2$Te$_3$ led to incremental improvements, but no breakthrough enhancement in $ZT$ was achieved.

More promising results ($ZT \sim 2.4$ for p-type material at RT) were achieved with Bi$_2$Te$_3$/Sb$_2$Te$_3$ superlattices produced by the low-temperature deposition.$^4$ A recent study indicated that the low-dimensional structuring of BiSbTe alloys$^5$ also allows for $ZT$ enhancement to $\sim 1.5$ at RT. But still higher $ZT$ values are needed for a major practical impact. It has been shown that $ZT$ above 3 or 4 at RT are needed in order to make thermoelectric cooling or power generation competitive with conventional methods.$^6$ Such an increase in $ZT$ would lead to a “thermoelectric revolution” and allow one for much more environmentally friendly power generation and cooling.

It follows from many theoretical predictions that a drastic improvement in $ZT$ can be achieved in low-dimensional structures where electrons (holes) are strongly confinement in one or two dimensions.$^7$ Hicks and Dresselhaus$^8$ predicted that $ZT$ can be increased in a Bi$_2$Te$_3$ quantum well by a factor of $\sim 13$ over the bulk value. This would require a complete carrier confinement in a quantum well with a width $H$ on the order of $\sim 1$ nm and an optimized position of the Fermi level. According to Dresselhaus et al.$^7,8$ quantum confinement of charge carries in quantum wells leads to a drastic $ZT$ improvement due to the increase in the carrier density-of-states (DOS) near the Fermi level and corresponding increase in the thermopower. The crucial condition for such mechanism is quantum confinement of carriers in quantum wells, which is only possible if materials are crystalline and essentially free of defects. The thickness of the thin film required to achieve the quantum confinement conditions has to be on the order of few atomic layers.
Note that in the superlattices commonly used in thermoelectric studies the charge carriers are only partially confined if confined at all due to the small potential barrier height and relatively low material quality. The barrier height has a pronounced effect on ZT. Broido and Reinecke\textsuperscript{9} have shown theoretically that ZT = 3 can be achieved in Bi\textsubscript{2}Te\textsubscript{3} superlattices with infinite potentials when the quantum well width (i.e., thickness of the thin film) is $H \approx 3$ nm. In the structures with incomplete quantum confinement the maximum ZT decreases to $\sim 2.5$ and the required width becomes as small as $\sim 2$ nm.

Balandin and Wang\textsuperscript{10} proposed a different strategy for increasing ZT in low-dimensional structures by reducing its thermal conductivity via spatial confinement of acoustic phonons, which carry bulk of heat in thermoelectric materials. The improvement of thermoelectric properties via phonon engineering\textsuperscript{10,11} also can be achieved in thin films or nanowires with the thickness of just few atomic layers and high quality of interfaces. In nanostructures with rough interfaces, the thermal conductivity can be reduced due to phonon scattering on boundaries and defects.\textsuperscript{12–14} At the same time, defects and disorder can also lead to electron mobility degradation limiting the improvement. The phonon confinement mechanism of the thermal conductivity reduction, proposed by Balandin and Wang\textsuperscript{10}, originates from the decreased phonon group velocity of the confined acoustic phonon modes, which results in the increased scattering on point defects.\textsuperscript{10,11} This mechanism works even in atomic films with smooth interfaces and can be utilized without strongly degrading the electron mobility.

Thus, in order to employ the full strength of the low-dimensional confinement effects for improving thermoelectric figure of merit either via the electron band-structure and phonon engineering one needs to produce quasi-two-dimensional (2D) structures with a few-atomic layer thickness and high-quality interfaces. Conventional chemical vapor deposition, electrochemical or other means, are not capable for producing such quality structures. Molecular beam epitaxy (MBE) of low-dimensional thermoelectric materials was also much less successful than that of optoelectronic or electronic materials due to the lattice mismatch and other factors. These considerations create very strong motivations for the search of alternative approaches to fabrication of the stacks of quasi-2D crystals made of Bi\textsubscript{2}Te\textsubscript{3}-based materials.

A few years ago interest in the stacked quasi-2D layers of bismuth telluride received an additional impetus from a totally different direction. It has been shown that stacks of quasi-2D layers of Te–Bi–Te–Bi–Te are members of a new type of recently discovered materials referred to as topological insulators.\textsuperscript{15–16} The surface state of a quasi-2D crystal of Bi\textsubscript{2}Te\textsubscript{3} is predicted to consist of a single Dirac cone. Moreover, it has been shown that the layered structures of related materials such as Bi\textsubscript{2}Se\textsubscript{3} and Sb\textsubscript{2}Te\textsubscript{3} are also topological insulators. The particles in topological insulators coated with thin ferromagnetic layers have manifested exotic physics and were proposed for possible applications in the magnetic memory where write and read operations are achieved by purely electric means. All these stimulate the search for methods to produce quasi-2D crystals of bismuth telluride even further.

In our recent brief report, we have shown a possibility of cleavage from bulk Bi\textsubscript{2}Te\textsubscript{3} of thin crystalline films and ribbons with the thickness of just a few atomic layers.\textsuperscript{17} In this letter, we present a complete description of the "graphene-inspired" mechanical exfoliation procedure from bulk Bi\textsubscript{2}Te\textsubscript{3}, which provides individual large-area quasi-2D crystals with many interesting properties. The van der Waals gaps, present in the Bi\textsubscript{2}Te\textsubscript{3} crystal structure, allowed us to disassemble the bulk crystal into its quintuple building blocks—five monoatomic sheets of Te(1)–Bi–Te(2)–Bi–Te(1), which have the thickness of $\sim 1$ nm. We carried out detail atomic force microscopy (AFM), scanning electron microscopy (SEM), micro-Raman spectroscopy, electrical current–voltage measurements, and thermal conductivity measurements to demonstrate the unusual properties of such quasi-2D Bi\textsubscript{2}Te\textsubscript{3} crystals and to demonstrate their potential for thermoelectric applications. Considering that Bi\textsubscript{2}Te\textsubscript{3} materials for the thermoelectric industry are as important as silicon (Si) and silicon oxide (SiO\textsubscript{2}) for the electronic industry, our results may have significant practical impact. The exfoliation and characterization procedures, described in this paper in detail, can lead to a new enabling technology for producing stacks of the low-dimensional thermoelectric films with complete quantum confinement of charge carriers and acoustic phonons. The described method for producing free-standing quasi-2D layers of Te(1)–Bi–Te(2)–Bi–Te(1) creates an impetus for investigation of topological insulators and their possible practical applications.

Bi\textsubscript{2}Te\textsubscript{3} has the rhombohedral crystal structure of the space group $D_\text{3d}^\infty$–R(−3)m with five atoms in one unit cell. The lattice parameters of the hexagonal cells of Bi\textsubscript{2}Te\textsubscript{3} are $a_0 = 0.4384$ nm and $c_0 = 3.045$ nm.\textsuperscript{14} Its atomic arrangement can be visualized in terms of the layered sandwich structure (see Figure 1). Each sandwich is built up by five monatomic sheets, referred to as quintuple layers, along the $c_0$ axis with the sequence $-[\text{Te(1)}–\text{Bi}–\text{Te(2)}–\text{Bi}–\text{Te(1)}]-[\text{Te(1)}–\text{Bi}–\text{Te(2)}–\text{Bi}–\text{Te(1)}]$–... Here superscripts (1) and (2) denote two different chemical states for the anions. The outmost atoms Te(1) are strongly bound to three planar Te(1) and three Bi metal atoms of the same quintuple layers and weakly bound to three Te(1) atoms of the next sandwich. The binding between adjacent Te(1) layers originates mostly from the weak van der Waals forces although other long-range Coulomb forces play a role in the bonding. The stronger bonds inside the quintuple layers are of the covalent or partially ionic nature. The presence of the van der Waals gap between the quintuples results in preferential cleavage plane between the adjacent Te(1) layers.
Through a mechanical cleavage process, we separated thin films from crystalline bulk Bi$_2$Te$_3$. The process was repeated several times to obtain layers with just a few atomic planes. Owing to the specific structure of Bi$_2$Te$_3$ crystal along the $c_0$ direction ($c_0 = 3.045$ nm is a very large lattice constant as compared to other materials), we were able to verify the number of layers using the optical inspection combined with atomic force microscopy AFM, SEM, and micro-Raman spectroscopy. The thickness of the atomic quintuple is $H \sim 1$ nm. The steplike changes in the cleaved layers highest of $\sim 1$ nm can be distinguished well with AFM. The produced atomic layers were placed on Si substrates containing a 300 nm thick SiO$_2$ capping layer. The silicon oxide thickness was selected by analogy with that for graphene on Si/SiO$_2$.\(^{18-21}\) We then isolated and separate individual crystal planes which exhibited high crystal quality with little to no structural defects. The mechanical cleavage of Bi$_2$Te$_3$ has led to a portion of quintuples with five atomic planes. In some cases we observed atomic planes with thickness smaller than that of the quintuple layers. The produced flakes had various shapes and sizes ranging from $\sim 2$ to $30 \mu$m. Some flakes had correct geometrical shapes indicative of the facets and suggesting a high degree of crystallinity. We selected large uniform Bi–Te flakes with dimensions of $\sim 20-30 \mu$m for fabrication of metal contacts for electrical characterization. For detailed material characterization, we suspended some of the Bi–Te atomic films over trenches in SiO$_2$/Si substrates. The trenches were fabricated by reactive ion etching (RIE). They had a depth of $\sim 500$ nm and widths ranging from 1 to $5 \mu$m. By suspending the ultrathin atomic films over these trenches, we reduced the coupling to the substrate. The latter allowed us to achieve a better understanding of the intrinsic properties of the atomically thin layers.

The isolated Bi–Te atomic layers were investigated using a high-resolution field-emission scanning electron microscope (XL-30 FEG) operated at $10-15$ kV. The diffraction patterns of the crystalline structures of the layers were studied using transmission electron microscopy (TEM). The sample preparation for TEM (FEI-PHILIPS CM300) inspection was carried out through ultrasonic separation in ethanol (C$_2$H$_5$OH) solution. The sonication was most effective with a Lo $F_{C2H5OH}$ solution where the molar concentration of Bi–Te atomic films was held at a constant $1.41 \times 10^{-5}$ mol/L throughout the solution. AFM studies were performed using a VEECO instrument with the vertical resolution down to $\sim 0.1$ nm. Raman spectroscopy was performed for better characterization. They had a depth of $\sim 500$ nm and widths ranging from 1 to $5 \mu$m. By suspending the ultrathin atomic films over these trenches, we reduced the coupling to the substrate. The latter allowed us to achieve a better understanding of the intrinsic properties of the atomically thin layers.

The quasi-2D quintuple layers are also of principle importance for the investigation of topological insulators.

In order to isolate bismuth telluride quintuples and break them into atomic planes, we employ a method similar to the one used for exfoliation of single-layer graphene.\(^{18-21}\) FIGURE 1. Schematic of Bi$_2$Te$_3$ crystal structure of $D_{2d}^8-R(-3)\bar{m}$ space group showing quintuple layers and location of the van der Waals gaps. The $\text{Te}^{(3)}$–$\text{Te}^{(4)}$ bond is the weakest while the $\text{Bi}–\text{Te}^{(1)}$ bond is the strongest. The mechanical exfoliation results in breaking the $\text{Te}^{(3)}$–$\text{Te}^{(4)}$ van der Waals bond and the formation of few-quintuples layers or quintuples.
surface. The low power levels were essential to avoid local laser heating, which was much more pronounced than in other material systems due to the extremely low thermal conductivity of Bi$_2$Te$_3$. The details of our Raman instrumentation and measurement procedures were reported by us earlier in the context of graphene investigation.\textsuperscript{22-24} The electrodes and contact pads for the ultrathin Bi$_2$Te layers on SiO$_2$ were fabricated and defined by the electron beam lithography (EBL) system (Leo 1550) followed by the metal deposition of 7 nm/70 nm Ti/Au metals with an electron beam evaporator (Temescal BJD-1800). The electrical measurements were carried out using a probe station (Signatone) at ambient conditions.

The quintuples, atomic trilayers, and bilayers were identified via combined optical, SEM, AFM, and TEM inspection. Our prior extensive experience with graphene\textsuperscript{22-24} was instrumental in our ability to separate weakly distinguishable optical features in Bi$\text{−}$Te atomic layers placed on SiO$_2$/Si substrates. A relatively large thickness of the unit cell (c$_H$ = 3.045 nm) made SEM and AFM identification rather effective. The representative high-resolution SEM micrographs and AFM images presented in Figure 2 show SEM, AFM, and TEM images of Bi$\text{−}$Te quasi-2-D crystals with lateral sizes ranging from a few micrometers to tens of micrometers. In Figure 2a, one can see a SEM micrograph of high-quality crystalline films with lateral dimensions of 1−4 µm and a thickness of a few-atomic planes. Due to the atomic thickness of the films the overlapping regions are seen with a very high contrast. The larger area flakes (>20 µm) tended to be attached to thicker Bi$_2$Te$_3$ films (Figure 2b). It was our experience that for thicker films the use of the tilted SEM images was more effective in

FIGURE 2. Images of quasi-2D bismuth telluride crystals showing (a) a SEM micrograph of the overlapping few-layer Bi$\text{−}$Te atomic crystals, (b) a large-area atomically thin crystal attached to thick Bi$_2$Te$_3$ film, (c) suspended films with visible quasi-2D layers, (d) suspended few-atomic-plane film, (e) an AFM micrograph of few-atomic-layer steps in cleaved films; and (f) a TEM micrograph of quasi-2D bismuth telluride film.
visualizing the quintuples and atomic-layer steps. Although [Te(1)–Bi–Te(2)–Bi–Te(1)] quintuple layers were more readily available among the separated flakes, some regions of flakes had sub-1-nm thickness and appeared as protruding few-atomic-plane films. Panels c and d of Figure 2 show suspended few-quintuple films. In Figure 2e we present a typical AFM image of steps in separated films with clear layered structure. One step with a height of ∼1 nm corresponds to a quintuple while two steps per a profile height change of ∼1 nm indicate subquintuple units (e.g., bilayer and a trilayer). A structural analysis at nanometer scale was carried out using TEM and the selected area electron diffraction (SAED) technique. The images for this type of characterization were taken with an electron beam energy of 300 kV. The exfoliated samples were dissolved in ethanol and placed on copper grids. The TEM image in Figure 2f shows that the exfoliated Bi–Te flakes dissolved in solution retain their flat structure and do not form clusters after being subjected to ultrasonic vibrations and processing.

In Figure 3a we present an electron diffraction pattern, which indicates that the separated atomically thin layers of bismuth telluride are crystalline after all processing steps. The elemental composition and stoichiometry of the atomically thin Bi–Te layers were studied by the energy dispersive spectrometry (EDS). The data were recorded for suspended films (like those shown in panels c and d of Figure 2). Representative EDS spectra for a suspended quasi-2-D crystal and a thick Bi2Te3 film (used as a “bulk” reference) are shown in panels b and c of Figure 3. Note that the most pronounced peaks in Figure 3b are those of Si and oxygen (O) proving the electron beam penetration through the suspended atomically thin film. The Si and O peaks are absent in Figure 3c for thick Bi2Te3 crystal, which absorbs the electron beam completely.

For one of the films, which had a thickness of ∼40 atomic planes (∼8 quintuple layers), and occupied an intermediate position between quasi-2D crystals and bulk Bi2Te3 crystals, we found that the molar contents of Bi and Te were found to be ∼54.7% and 65.3%, respectively. Although the film is crystalline and the stoichiometry for the [Te(1)–Bi–Te(2)–Bi–Te(1)] quintuple layers is preserved, one can talk about an apparent deviation from the stoichiometry due to the fact that the film is not truly bulk. For the large bulk bismuth telluride crystals used for exfoliation of the ultrathin films, we consistently found a 40–60% ratio of Bi to Te corresponding to a Bi2Te3 formula. The analysis of the measured EDS spectrum of the suspended film, which made up ∼10% of the total wt %, had a molar content percentage between Bi and Te of ∼33.2% and 66.8%, respectively. Thus, the structural make up of that particular ultrathin film has 1 to 2 ratio of Bi to Te atoms (e.g., Te–Bi–Te), which differs strongly from conventional bulk crystals.

The possibility of changing the “effective” atomic composition in the crystalline ultrathin films is very important for practical applications. It is known from the extensive studies of the thermoelectric properties of bismuth telluride that a small small variation of ∼0.1% in the Bi to Te atomic ratio can change the properties of the material from p-type to n-type.25 Intentional deviation from stoichiometry during synthesis of bismuth telluride compounds and alloys has been conventionally used for “doping” this type of material.26 The close-to-stoichiometric Bi2Te3 is of p-type with a free carrier concentration of approximately 1019 cm−3. A shift to excess Te leads to an n-type material. Since our atomically thin films are crystalline, the “stoichiometric doping” may...
phonons with the $A_{2u}$ are optical phonons while the remaining three are acoustic (i.e., perpendicular to the film plane), respectively. We focus our analysis on the phonon peaks in the spectral range from $25 \text{ cm}^{-1}$ to $250 \text{ cm}^{-1}$. These peak positions are very close to the previously measured and assigned Raman peaks of bulk crystalline Bi$_2$Te$_3$. Richter et al. in their detail study of phonons in Bi$_2$Te$_3$ provided the following frequencies (in their notation): $154 \text{ cm}^{-1}$ for $A$, $105 \text{ cm}^{-1}$ for $E_g$, and $120 \text{ cm}^{-1}$ for $A_{1u}$. The $A_{1u}$ peak is likely to become Raman active due to the symmetry breaking in atomically thin films. One can notice that the out-of-plane vibrations (at $\sim 137 \text{ cm}^{-1}$ and $\sim 119 \text{ cm}^{-1}$) in the suspended Bi–Te atomic films have higher intensity. The latter may be an indication of the enhancement of these vibration modes in the atomically thin films, which are not supported by the substrate. The Raman study confirms that the exfoliated films are crystalline and atomically thin. A systematic study of the changes in Raman spectrum due to modification of the vibration modes in the exfoliated ultrathin films suspended or supported on the substrate was complicated due to pronounced local heating effects.

Bulk single crystal Bi$_2$Te$_3$ is known to have very low thermal conductivity of $\sim 1.5-2.0 \text{ W/(m K)}$ along the cleavage plane and $0.6 \text{ W/(m K)}$ along the van der Waals bonding direction. It also has a low melting point of $573 \degree\text{C}$. The local laser heating was a major problem when we tried to increase the excitation power to the levels conventionally used for other materials. The maximum excitation power of the Ar$^+$ laser (with the wavelength of 488 nm) used in this study was 10 mW. Approximately half of the excitation power reaches the sample surface after transmission through the optical system. The use of the power levels above 0.5 mW (corresponding to $\sim 0.22 \text{ mW}$ on the sample) resulted in appearance of the holes due to local melting or oxidation of the atomically thin flakes as seen in the inset to Figure 5. In this image 100% corresponds to the power of 10 mW set at the laser. We observed reproducibly that the diameter of the laser burned holes was growing with increasing excitation power (the exposure time for each spot was 100 s). Figure 5 shows an evolution in Raman spectra of Bi–Te atomic layers as the excitation power changes. When the power is too low (0.1 mW), no spectrum is excited. The excitation power of 0.5 mW provides meaningful spectra, which are in line with those obtained for bulk Bi$_2$Te$_3$ (at this power level no hole-burning or other laser-induced structural disorder was observed in microscopy images). As the power grows higher than 0.5 mW the Raman spectrum begins to change as a result of the local melting or oxidation of the material. No laser damage was observed for the bulk Bi$_2$Te$_3$ at these power levels. For this reason, the selection of the right excitation power for Raman spectroscopy of the atomically thin Bi–Te layers is crucial for obtaining informative phonon bands. The drastically different reaction of the films on laser heating confirms their few-atomic layer thickness.

The observed easy local heating damage to Bi–Te atomic flakes was in sharp contrast to graphene, a material char-
charized by extremely high thermal conductivity.\textsuperscript{31,32} We were able to use much higher laser power on suspended graphene without inflicting any damage to its lattice. The heat conduction in strictly 2D systems is a complicated subject deserving special consideration. The thermal conductivity of conventional thin films usually decreases with decreasing film thickness as a result of the acoustic phonon–boundary scattering.\textsuperscript{12,13} At the same time, it is also known that the thermal conductivity limited by crystal anharmonisity (also referred to as intrinsic) has a logarithmic divergence in a strictly 2D system.\textsuperscript{33} This anomalous behavior of the 2D thermal conductivity has been studied extensively for many different crystal lattices and atomic potentials.\textsuperscript{34,35} One needs disorder (e.g., extrinsic scattering mechanisms) in order to obtain a finite value of the thermal conductivity in 2-D systems or limit the lateral size of the system.\textsuperscript{33–35} In our case of Bi–Te flakes, the samples had a thickness of several atomic layers (not exactly 2D system but rather a quasi-2D) and the extrinsic effects were dominant. Due to the very low thermal diffusivity and thermal conductivity of Bi\textsubscript{2}Te\textsubscript{3} crystals at first place, the induced heat had not escaped fast enough from the local spots leading to the lattice melting and observed lattice damages. As a consequence, for thermoelectric applications, it would be better to use stacks of bismuth telluride quintuple layers, put one on top of the other, rather than atomic bilayers. Indeed, quintuples are more mechanically robust and expected to have even lower thermal conductivity than Bi\textsubscript{2}Te\textsubscript{3} bulk values. In our initial report\textsuperscript{17} on the atomically-thin crystalline films of Bi\textsubscript{2}Te\textsubscript{3}, we were not able to present quantitative data for their thermal conductivity. Below, we report the results of the measurement of the thermal properties of the stacks of the mechanically exfoliated Bi\textsubscript{2}Te\textsubscript{3} films.

It is also important to understand if the electrical conductivity of bismuth telluride undergoes changes after it was structured to the large-area films with the thickness of just few quintuples. For room temperature transport measurements Bi–Te devices with a bottom gate and two top metal contacts were prepared (see inset to Figure 6). The RT current–voltage characteristics shown in Figure 6 reveal a weak nonlinearity and rather low electrical resistivity on the order of $10^{-4}$ $\Omega$ m. This value (which includes contact resistance) is comparable to the resistivity values measured for evaporated Bi\textsubscript{2}Te\textsubscript{3} films used in thermoelectric devices.\textsuperscript{36,37} The latter suggests that the charge carriers are not depleted in the samples and that the atomically thin bismuth telluride films retain their electrical properties. We did not observe a strong gating effect for Bi–Te devices while sweeping the back gate bias from $-50$ to $50$ V. That was in sharp contrast to our experiments with the back-gated graphene and few-layer graphene devices.\textsuperscript{38,39} In the fabrication of graphene and Bi–Te devices we followed similar procedures and used the same heavily doped Si/SiO\textsubscript{2} wafers. One possible explanation of the weak gating in Bi–Te atomic films can be a strong doping of the flakes due to the “stoichiometric doping” discussed above. The charge accumulation at the interfaces terminated with either Bi or Te atoms can screen the electric field produced by the back gate.

The described electrically conducting bismuth telluride quasi-2D crystals can be used as quantum wells with nearly infinite potential barriers for thermoelectric applications. The charge carriers and acoustic phonons in the crystalline quintuple layers with the thickness of $\sim 1$ nm will be strongly confined spatially. At the same time, any practical application of thermoelectric nanostructures requires a sufficient “bulk” volume of the material for development of the temperature gradient, in the case of cooling, or voltage, in the case of power generation. An individual quantum well would not be suitable. For this reason, we envisioned a
practical method for utilization of Bi–Te quasi-2D crystals by stacking exfoliated films one on top of the other. The obtained “stacked superlattices” are expected to retain the useful properties of individual atomic films such as quantum confinement of charge carriers and reduced phonon thermal conductivity. Indeed, the potential barriers for charge carriers in such crystalline films remain very high unlike in the epitaxially grown Bi₂Te₃-based superlattices with the lattice matched barriers where the band offsets are small. The thermal conductivity in the mechanically separated and stacked layers is reduced due to the acoustic phonon—rough boundary scattering or acoustic phonon spatial confinement in exactly the same way as in the individual films. We experimentally tested a possibility of ZT enhancement in stacks of relatively thick exfoliated films by measuring the thermal conductivity and Seebeck coefficient, and comparing them with those of the reference Bi₂Te₃ bulk crystals, which were used for the exfoliation of the films.

The thermal conductivity \( K \) of the prototype stacked exfoliated films was determined by two different methods: the laser-flash (Netszch LFA) and the transient planar source (TPS) technique (Hot Disk). Both techniques have been “calibrated” via comparison with the values obtained with the in-house built 3-\( \omega \) method,\(^ {41-43} \) which is considered to be a standard technique for thin films. We have previously successfully used 3-\( \omega \) measurements for electrically insulating thin films with the thickness down to \( \sim 1 \) nm.\(^ {44} \) The Seebeck coefficient of stacked films was determined using the MMR system (SB100) consisting of two pairs of thermocouples. Details of the measurements are provided in the Methods. We found significant drop in the cross-plane (in-plane) thermal conductivity from \( \sim 0.5-0.6 \) W/(m K) \( \sim 1.5-2.0 \) W/(m K) in bulk reference to \( \sim 0.1-0.3 \) W/(m K) \( \sim 1.1 \) W/(m K) in the stacked films at RT. The thermal conductivity of stacked superlattices revealed a very weak temperature dependence suggesting that the acoustic phonon transport was dominated by the boundary scattering. It is interesting to note that the measured cross-plane \( K \) value is close to the minimum thermal conductivity for Bi₂Te₃ predicted by the Cahill model,\(^ {45} \) which gives the low bound of \( \sim 0.12 \) W/(m K). We have not observed substantial changes in the thermal power beyond experimental uncertainty with the measured Seebeck coefficient \( \sim 254 \mu V/K \) only slightly above its bulk reference value. The latter was attributed to the fact that the Fermi level was not optimized in these films. More research is needed to gain complete control of the carrier densities in the mechanically exfoliated films. At the same time, the measured decrease of the thermal conductivity results in the estimated ZT enhancement by about 30–40\% of its bulk value. Additional \( Z \) increase in a wide temperature range can be achieved with the cross-plane electrical gating of the Bi–Te atomic films. Some of us have recently shown theoretically\(^ {46} \) that a combination of quantum confinement of carriers and perpendicularly applied electric field in bismuth telluride nanostructures can be effective for \( Z \) improve-ment. The developed an exfoliation technique can also be extended to other thermoelectric material systems.\(^ {47} \) This approach is particularly promising for the thermoelectric cooling applications at low temperature because the effect is even more pronounced owing to stronger suppression of the thermal conductivity.

In conclusion, using the procedures similar to those developed for graphene mechanical exfoliation, we were able to produce high-quality bismuth telluride crystals with a thickness of few atoms. Following the initial report on the possibility of exfoliation of Bi₂Te₃,\(^ {17} \) we performed detail characterization of the suspended quasi-2D atomic crystals of bismuth telluride using SEM, TEM, EDS, AFM, SAED, micro-Raman spectroscopy and electrical and thermal measurements. We established that by altering the thickness and sequence of atomic planes one can create “designer” non-stoichiometric crystalline films and change their properties. The electrical back-gating was found to be weak, possibly due to the non-stoichiometric doping and the interface change screening. The Raman spectra reveal differences from those of bulk crystals, which can potentially be used for nanometrology of such films. The “stacked superlattices” made of the mechanically exfoliated bismuth telluride films have shown reduced thermal conductivity and enhanced thermoelectric properties. The obtained results may lead to completely new scalable methods for producing low-dimen-sional thermoelectrics and atomic-layer engineering of their properties. The described technology for producing free-standing quasi-2D layers of Te–Bi–Te–Bi–Te can be used for investigation of the topological insulators and their possible practical applications.

**Methods.** The first technique used for \( K \) measurements is the laser-flash technique (Netszch LFA). By timing the heat pulse propagation through our samples of known thicknesses, we applied the transient method to measure the thermal diffusivity and thermal conductivity. The experimental setup was equipped with an adjustable xenon flash lamp for heating the sample on one end while a contactless IR detector was used to measure the temperature rise at the other end. The specific instrument used for this study had a capability to measure \( K \) in the range from below 0.1 to 2000 W/(m K). We have previously “calibrated” the laser-flash measurement technique with other standard methods for measuring thermal conductivity available in our laboratory.\(^ {41-44} \) Due to the geometry of the setup the measured \( K \) has to be interpreted as mostly cross-plane component of the thermal conductivity tensor. In the experiments the light pulse “shot” hit the sample and a temperature rise was measured by an InSb IR detector. The thermal conductivity is defined as \( K = a p C_p \), where \( a \) is the thermal diffusivity of the film determined in the experiment as \( a = 0.139 R t_{1/2} \), where \( t_{1/2} \) is the measured half-rise time of temperature, \( C_p \) is the heat capacity, and \( p \) is the mass density of the material. For the numerical analysis of the experimental data, we used several theoretical approaches, including the Parker, Cowan,
and Clark-Taylor analysis. These analysis curves were plotted with an experimental temperature curve rise in order to extrapolate diffusivity and correct the result for heat loss to side-walls of a sample holder. The bismuth telluride films were prepared from the bulk Bi$_2$Te$_3$ crystals and stacked on a Corning glass substrate. The original Bi$_2$Te$_3$ crystal was used as a bulk reference. The laser-flash measurements revealed the RT thermal conductivity of the stacked films to be $\sim 0.1 \pm 0.3$ W/(m K), which is significantly lower than that of the bulk reference sample ($K = 0.5 \pm 0.6$ W/(m K) for cross-plane and $K = 1.5 \pm 2.0$ W/(m K) for in-plane). Our results for the reference bulk Bi$_2$Te$_3$ crystal and thin films are in agreement with previously reported data for bulk and Bi$_2$Te$_3$-based nanoparticles.30,48

The second TPS technique (Hot Disk) provided $K$ values, which correspond to an averaged in-plane component of the thermal conductivity. In the TPS measurements, a thin Ni heater-sensor covered with a thin electrically insulating layer was sandwiched between two stacked films under test. The samples were heated by short electrical current pulses for a few seconds. The temperature rise in response to the dissipated heat was determined from the change in the resistance of the sensor. The time dependence of the temperature rise was used to extract the thermal conductivity from the equation $\Delta T(\tau) = P(\tau^{3/2}/K)^{-1}D(\tau)$, where $\tau$ is the parameter related to the thermal diffusivity $\alpha$ and the transient measurement time $\tau_m$ through the expression $\tau = (\tau_m \alpha^{2}/r^{2})^{1/2}$, $r$ is the radius of the sensor, $P$ is the input power for heating the sample, and $D(\tau)$ is the modified Bessel function. The RT values obtained for thermal conductivity were $\sim 1.1$ W/(m K), which also represent a significant drop compared to the bulk reference. The Seebeck coefficient was determined using MMR system (SB100) consisting of two pairs of thermocouples. One pair was formed with the junctions of copper and the layers under test. We modified the sample stage of the system in order to be able to use it with our thin films. The computer-controlled sample stage was attached to the cold stage refrigerator and provides a preset stable temperature during the measurement. The sample chamber was kept at pressure below 10 mTorr while in operation. The measured value was about $\sim 254$ µV/m at RT.

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REFERENCES AND NOTES


